## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Jack O. Chu, Basanth Jagannathan, Alfred Grill, Bernard S. Meyerson and John A. Ott

(to be assigned) Serial No.:

Group Art No:

Filed:

herewith

Examiner:

For: Epitaxial and Polycrystalline Growth of  $\dot{\text{Si}}_{1-x-y}\text{Ge}_x\text{C}_y$ and  $Si_{i-y}C_y$  Alloy Layers on Si by UHV-CVD

ASSISTANT COMMISSIONER FOR PATENTS BOX PATENT APPLICATION WASHINGTON, D. C. 20231

## EXPRESS MAIL CERTIFICATE

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Date of Deposit April 20, 2001

I hereby certify that the following attached paper or fee

Acknowledgment Post Card; 1.

Application Transmittal Sheet (in duplicate); 2.

Application Filed Under Rule 1.53(f) (Missing Parts) 3. with unsigned declaration attached; and

Set of eleven (11) Informal Drawings

is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and is addressed to the

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/: Y0920010308US1 CASE DOCKET DATE: April 20, 2001

Transmitted herewith for filing under rule 1.53(f) is the Patent Application of:

Inventors: Jack Oon Chu, Basanth Jagannathan, Alfred Grill,

Bernard Steele Meyerson and John A. Ott

ASSIGNEE NAME: International Business Machines Corporation ASSIGNEE RESIDENCE: Armonk, New York

For: Epitaxial and Polycrystalline Growth of Si<sub>1-x-y</sub>Ge<sub>x</sub>C<sub>y</sub> and Si<sub>1-v</sub>C<sub>v</sub> Alloy Layers on Si by UHV-CVD

## Enclosed are:

IJ

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X 11 Sheets of Informal Drawings.

An assignment of the invention to International Business Machines Corporation, Armonk, New York 10504. Ü

\_ A certified copy of a \_\_\_\_\_ application number \_\_\_\_\_

(Unsigned) Declaration and Power of Attorney is attached to the application. Ш

Associate Power of Attorney.

Information Disclosure Statement with form PTO-1449 with references attached.

The filing fee has been calculated as shown below:

(Col. 1) (Col. 2)

	1	
FOR:	NO. FILED	NO. EXTRA
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TOTAL CLAIMS	59 - 20 =	39
INDEP CLAIMS	5 - 3 =	2
MULTIPLE DEPENDENT CLAIM PRESENTED		

If the difference in Col. 1 is less than zero, enter "0" in Col. 2.

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